

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: YOUNG HOON PARK, ET AL.	)
	) Group Art Unit: 1762
Serial No.: 10/716,950	)
	)
Filed: November 19, 2003	) Examiner:
	) Stouffer, Kelly M.
For: METHOD OF DEPOSITING THIN FILM	)
USING ALUMINUM OXIDE	) Confirmation No. 7281

**RESPONSE TO OFFICE ACTION**

**VIA FACSIMILE 571-273-8300**

Mail Stop Non-Fee Amendment

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir: .

Applicants respectfully request entry of the following amendment and remarks contained herein in response to the Office Action mailed August 18, 2006. Applicants respectfully submit that the amendment and remarks contained herein place the instant application in condition for allowance.

**Amendments to the specification** are reflected on page 2 of this paper.

**Amendments to the claims** are reflected in the listing of claims, which begins on page 4 of this paper.

**Remarks** begin on page 6 of this paper.